

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re Application of: OKINO

Application No. 09/942,856

Filed: August 29, 2001

METHODS FOR MANUFACTURING For:

RETICLES FOR CHARGED-PARTICLE-BEAM

MICROLITHOGRAPHY EXHIBITING REDUCED PROXIMITY EFFECTS, AND RETICLES PRODUCED USING SAME

Examiner: Lam S. Nguyen

Date: August 4, 2003

MAIL STOP AMENDMENTS **COMMISSIONER FOR PATENTS** P.O. BOX 1450 **ALEXANDRIA, VA 22313-1450**

Art Unit: 2853

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service on August 4, 2003 as First Class Mail in an envelope addressed to: MAIL STOP AMENDMENTS, COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450.

ANDRIA, VA 22313-1450

AMENDMENT AND REPLY TO OFFICE ACTION

This responds to the Office action dated February 4, 2003. Please amend the referenced application as follows:

Amendments to the Specification begin on page 2.

Remarks begin on page 3.